

P-712 Low-Profile Piezo Scanner

Compact OEM System



P-712 piezo scanner with up to 40 µm travel range

- High Dynamic, to 5 ms Settling Time
- Travel Range up to 40 µm
- Resolution to 0.2 nm
- Compact Design with Low Profile, 40 x 40 x 6 mm
- Clear Aperture 25 x 15 mm
- PICMA® High-Power Actuators

P-712 piezo scanners are ideal for applications where limited space requires small-sized equipment. The high resonant frequency allows for fast linear scanning with 30 µm travel in one axis and provides settling times of about 5 ms. The P-712 linear scanner is offered in two versions, one with SGS position sensors for closed-loop operation, and one without sensors for open-loop.

Application Examples

- Optical path tuning
- Biotechnology
- Medical technology
- Image processing / stabilization
- CCD / CMOS camera technology

A similar XY version is available with product number P-713 / P-714 (see p. 2-56).

Excellent Guiding Accuracy

Flexures optimized with Finite Element Analysis (FEA) are used to guide the stage. FEA techniques are used to give the design the highest possible stiffness in, and perpendicular to, the direction of motion, and to minimize linear and angular runout. Flexures allow extremely high-precision motion, no matter how minute, as they are completely free of play and friction.

Electric discharge machining (EDM) with fine cutting wires is used to obtain the required precision for the flexures which make up the guidance system and determine the stiffness.

Optional Position Control

High-resolution, broadband, strain gauge sensors (SGS) are applied to appropriate locations on the drive train and measure the displacement of the moving part of the stage relative to the base indirectly. The SGS sensors assure optimum position stability in the nanometer range and fast response.

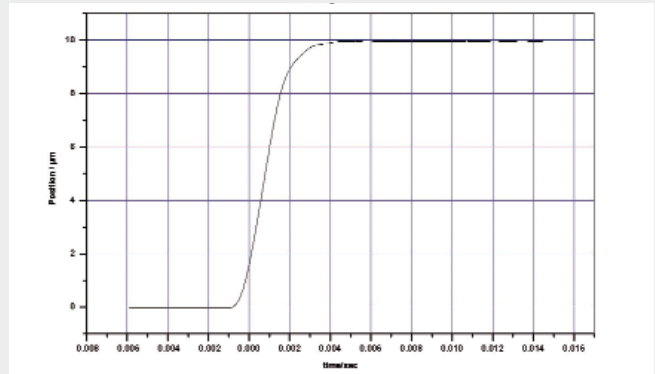
Ceramic Insulated Piezo Actuators Provide Long Lifetime

Highest possible reliability is assured by the use of award-winning PICMA® multilayer piezo actuators. PICMA® actuators are the only actuators on the market with ceramic-only insulation, which makes them

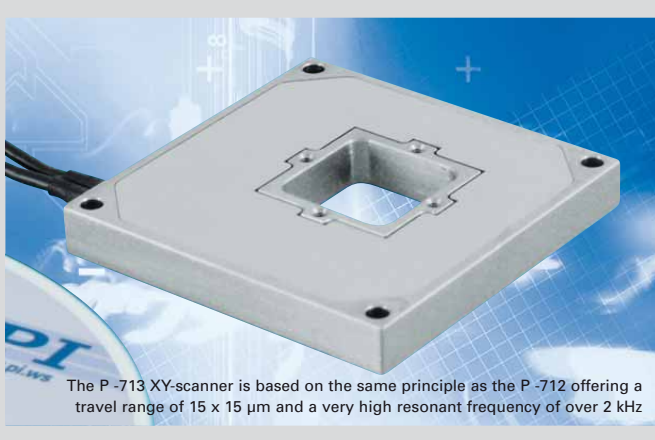
Ordering Information

- P-712.10L**
Low-Profile OEM Nanoscanner,
40 µm, Open-Loop
- P-712.1SL**
Low-Profile OEM Nanoscanner,
30 µm, SGS-Sensor

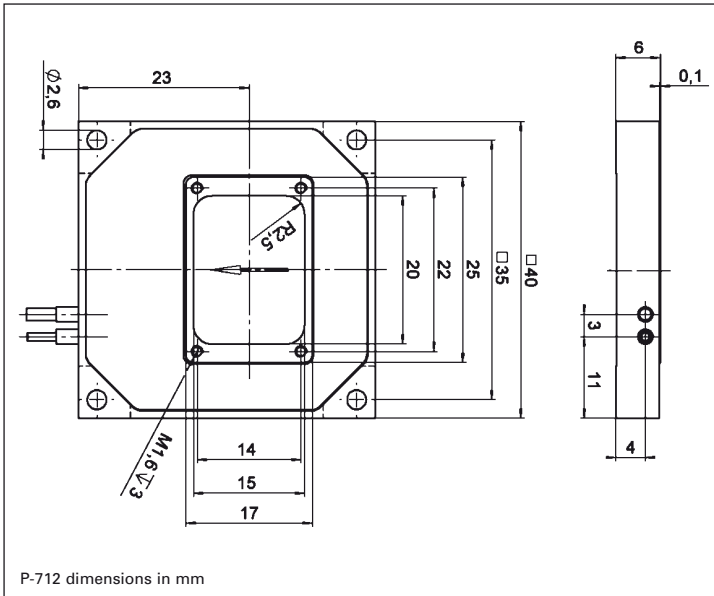
resistant to ambient humidity and leakage-current failures. They are thus far superior to conventional actuators in reliability and lifetime.



Settling time for the P-712 at 30 µm is in the 5 ms range



The P-713 XY-scanner is based on the same principle as the P-712 offering a travel range of 15 x 15 µm and a very high resonant frequency of over 2 kHz



Technical Data

Model	P-712.1SL	P-712.10L	Units	Tolerance
Active axes	X	X		
Motion and positioning				
Integrated sensor	SGS	–		
Open-loop travel, -20 to +120 V	40	40	µm	min. (+20%/0%)
Closed-loop travel	30	–	µm	calibrated
Closed-loop resolution	2	–	nm	typ.
Open-loop resolution	0.2	0.2	nm	typ.
Linearity, closed-loop	0.3	–	%	typ.
Repeatability	±5	–	nm	typ.
Pitch	±5	±5	µrad	typ.
Yaw	±20	±20	µrad	typ.
Mechanical properties				
Stiffness in motion direction	0.6	0.6	N/µm	±20%
Unloaded resonant frequency	1550	1550	Hz	±20%
Resonant frequency under load	1090 (20 g)	1090 (20 g)	Hz	±20%
Push/pull force capacity in motion direction	6	6	N	Max.
Load capacity	5	5	N	Max.
Lateral Force	6	6	N	Max.
Drive properties				
Ceramic type	PICMA® P-882	PICMA® P-882		
Electrical capacitance	0.3	0.3	µF	±20%
Dynamic operating current coefficient	1.3	1.3	µA/(Hz • µm)	±20%
Miscellaneous				
Operating temperature range	-20 to 80	-20 to 80		
Material	Stainless steel	Stainless steel		
Dimensions	40 x 40 x 6	40 x 40 x 6	mm	
Mass	0.095	0.095	kg	±5%
Cable length	1.5	1.5	m	±10 mm
Voltage connection	LEMO	LEMO		
Sensor connector	LEMO	–		

Recommended controller / amplifier

Single-channel (1 per axis): E-610 servo controller / amplifier (p. 2-110), E-625 servo controller, bench-top (p. 2-114)

Linear Actuators & Motors

Nanopositioning / Piezoelectrics

Piezo Flexure Stages / High-Speed Scanning Systems

Linear

Vertical & Tip/Tilt

2- and 3-Axis

6-Axis

Fast Steering Mirrors / Active Optics

Piezo Drivers / Servo Controllers

Single-Channel

Multi-Channel

Modular

Accessories

Piezoelectrics in Positioning

Nanometrology

Micropositioning

Index